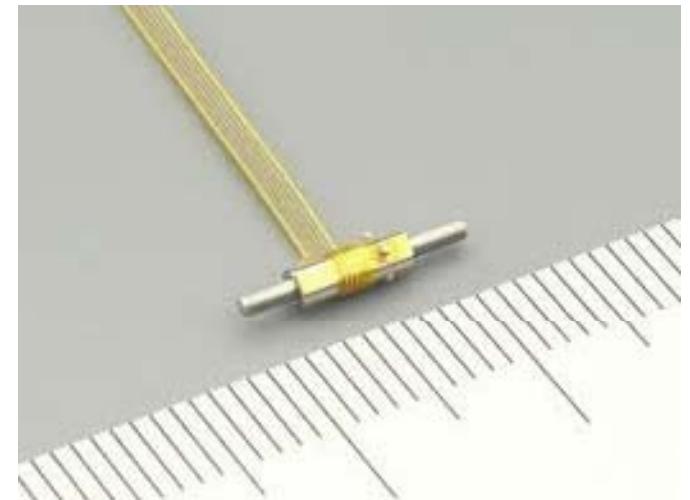
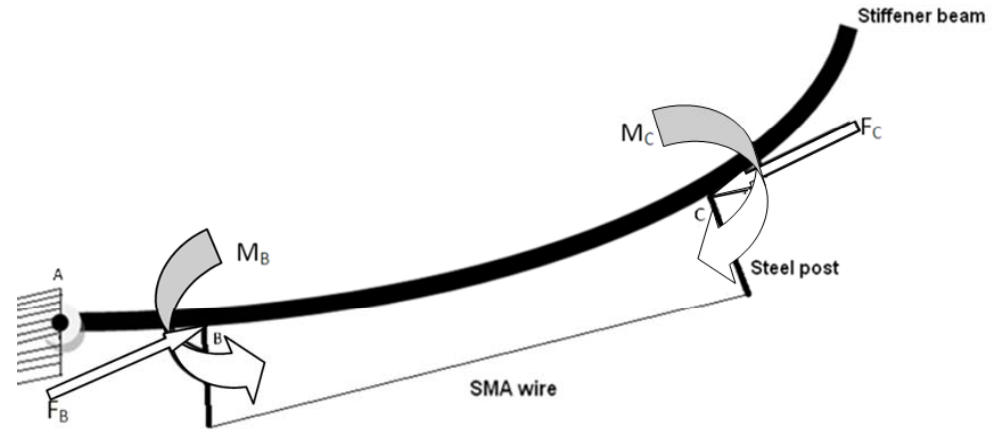


APA230L, APA150M, APA100S

## Module 5: Actuators & Sensors based on HBLS Smart Materials

Bishakh Bhattacharya and Nachiketa Tiwari  
Department of Mechanical Engineering  
Indian Institute of Technology, Kanpur





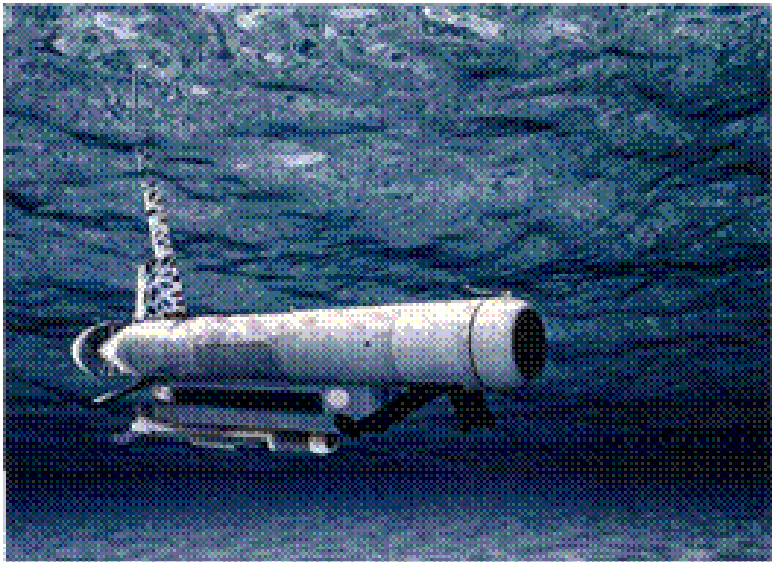
## LECTURE 36

# Delamination Sensing and Vibration Control using Magnetostrictive Materials (Part 2)

# Organization of this Lecture

- Symmetric Laminate with Magnetostrictive Sensor
- Asymmetric Laminate with Magnetostrictive Sensor
- Sensing Delamination: Results of Numerical Analysis

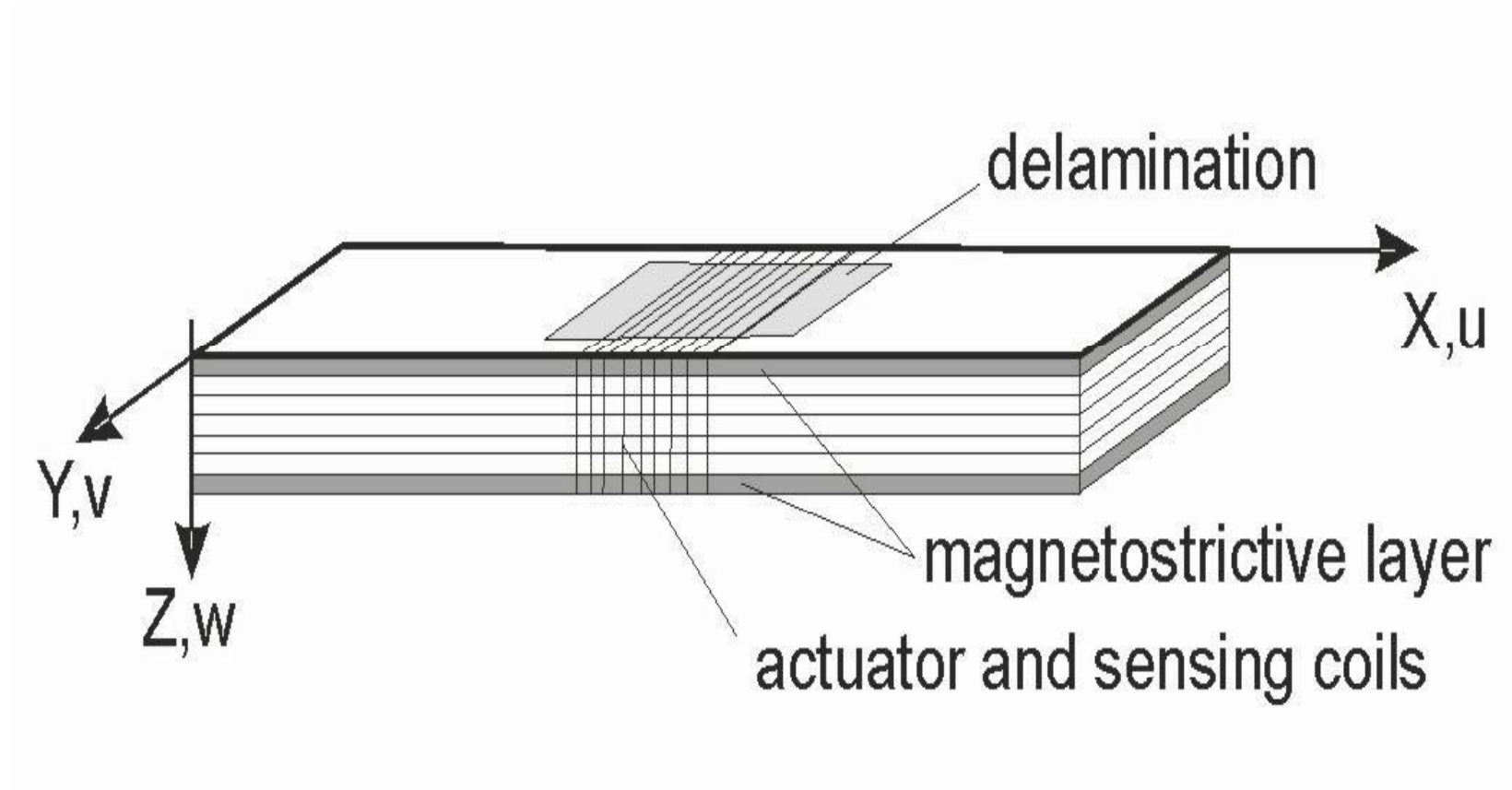
## Magnetostrictive Material: High Bandwidth-Moderate Strain Actuation



- **DC to 3 KHz Bandwidth**
- **Force availability reported up to 1700 N**
- **Free Strain: 3000 micron**

TALON (Tactical Acoustic Littoral Ocean Network) sonar system uses Magnetostrictive Terfenol-D for under-water submarine detection, source: Etrema Products

# Smart laminate beam



## Symmetric/Asymmetric laminate

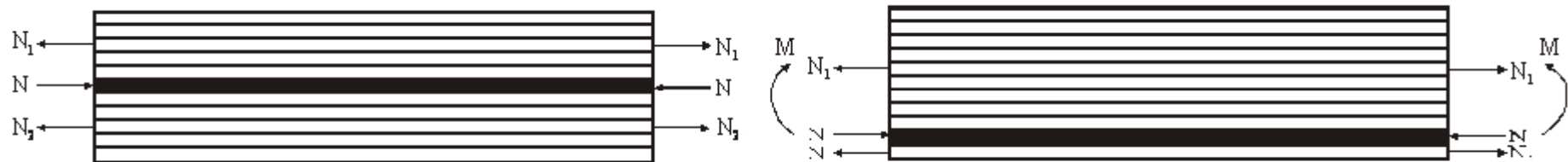


Fig 1 (a) Forces on the symmetric beam (b) Moment on asymmetric beam due to stresses induced in the magnetostrictive layer

Net Force in magnetostrictive layer (Compressive)  $N = \sigma h_m$

Forces in upper & lower segment  $N_1 = A_1 \varepsilon$  &  $N_2 = A_2 \varepsilon$

If no external force is applied

$$N = N_1 + N_2$$

$$\text{Strain } \varepsilon = N / (A_1 + A_2)$$

$$\text{Stress } \sigma = \alpha I$$

$$\alpha = \frac{dN}{\left[ \frac{h_m}{A_1 + A_2} - S^H \right]}$$

## Asymmetric composite laminate (...contd..)

Moment on the beam due to stresses induced in the magnetostrictive layer

$$M = N_1 a + N_2 c - N b$$

Mid plane curvature

$$\lambda = \frac{M - B\varepsilon}{D}$$

Axial strain/stress in magnetostrictive layer including the effect of bending

$$\varepsilon' = \varepsilon - z_k \lambda$$

$$\sigma' = \frac{1}{S} [\varepsilon' - d n I_0 \sin \omega t]$$

## Failure criterion (Griffith's)

Delamination will be initiated when stress intensity factor

$K_I$

exceeds critical stress intensity factor

$K_{IC}$

$$K_I \geq \beta \cdot K_{IC}$$

$$K_I = \sigma \sqrt{\pi \cdot C}$$



## Failure criterion (Tsai-Wu)

$$F_1\sigma_1 + F_{11}\sigma_1^2 + F_2\sigma_2 + F_{22}\sigma_2^2 + 2F_{12}\sigma_1\sigma_2 + F_{66}\tau_{12}^2 = 1$$

$$F_1 = 1/X_\tau + 1/X_\varsigma \quad F_{11} = -1/X_\tau X_\varsigma$$

$$F_2 = 1/Y_\tau + 1/Y_\varsigma \quad F_{22} = 1/Y_\tau Y_\varsigma$$

$$F_{66} = 1/S^2$$

## Voltage analysis

Symmetric laminate

$$B = (d\alpha + \mu N) I$$

$$V = -nla_r (d\alpha + \mu N) I_0 \omega \cos \omega t$$

Asymmetric laminate

without mechanical loading

$$V' = -nla_r (d\alpha' + \mu N) I_0 \omega \cos \omega t$$

with mechanical loading

$$V'' = -nla_r \left[ d \left[ \bar{Q} \right] (\varepsilon_0' + z_k \lambda') + \mu n I_0 \right] \omega \cos \omega t$$

**Table 1: Numerical details used in analysis**

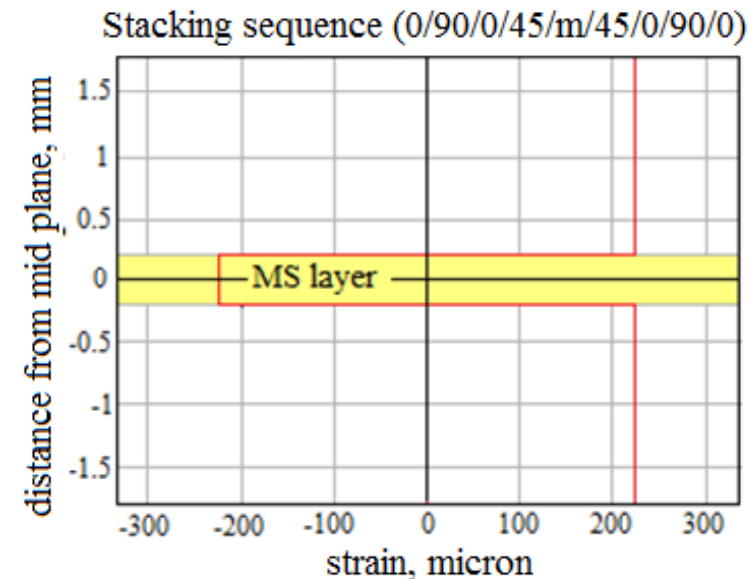
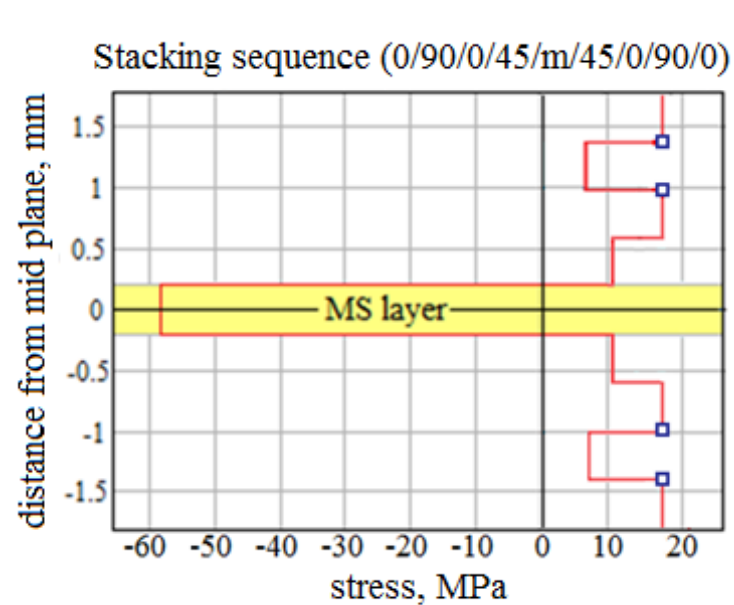
Number of plies including MS layer	9
Symmetric laminate stacking	[0/90/0/45/m/45/0/90/0]
Asymmetric laminate stacking	[0/90/0/45/0/90/m/90/0]
Composite used	carbon - epoxy
Elastic modulus of carbon fibers	350 GPa
Elastic modulus of epoxy matrix	3.50 GPa
Elastic modulus of Terfenol- D	30 GPa
Volume fraction of fiber	0.16
Volume fraction of Terfenol-D	0.0224
Poisson's ratio of carbon fiber	0.3
Poisson's ratio of epoxy matrix	0.4
Poisson's ratio for Terfenol-D	0.25

## Table 1: Numerical details (...Contd.)

• Number of turns in the coil per meter length of beam	1000
• Carrier frequency	1000Hz
• Carrier current	0.4 A
• Piezomagnetic coefficient	$1.5 \text{ e}^{-8} \text{ m/A}$
• Permeability	$14.13\text{e}^{-7}$
• Coupling coefficient of Terfenol-D	0.75
• Tensile strength of Terfenol-D	28 MPa
• Compressive strength of Terfenol-D	700 MPa
• Fracture toughness of MS layer	$30 \text{ MPa}\cdot\text{m}^{1/2}$
• Size of crack at delamination	2 mm
• Length of beam	100 mm
• Width of over all beam structure	20 mm
• Thickness of composite lamina	0.4 mm
• Thickness of MS layer	0.4 mm

# Results of analysis

## Stress and strain variations at various interfaces and in MS layer (actuator current only)

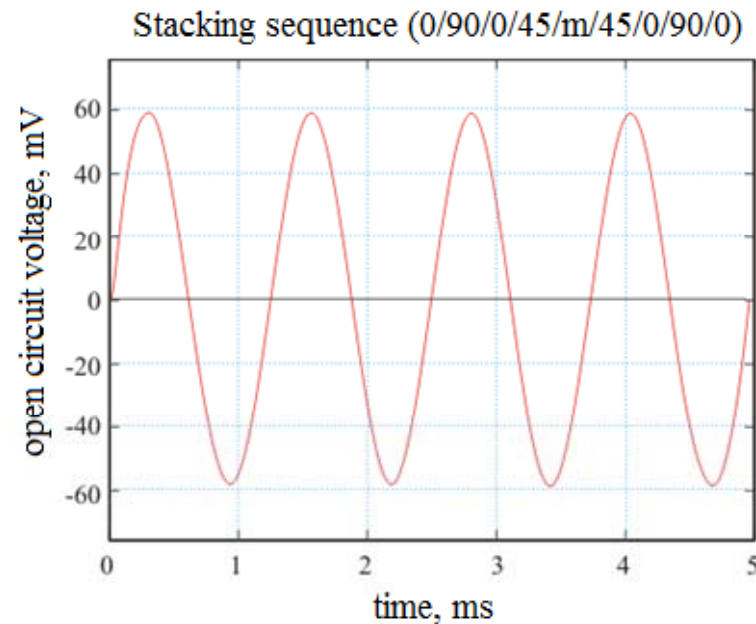


**Symmetric laminate**

**Fourth IPS International Symposium, Waseda University, Japan**

November 17-19, 2010

## Open circuit voltage in MS layer at the time of delamination (actuator current only)



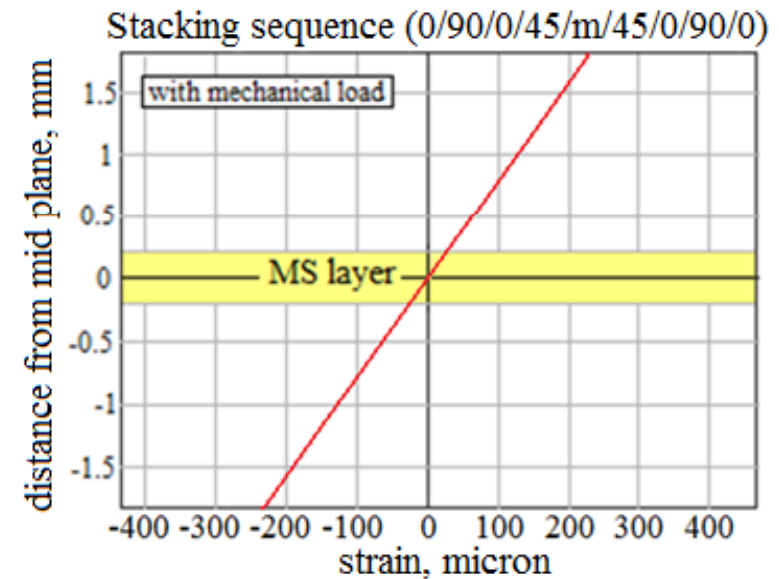
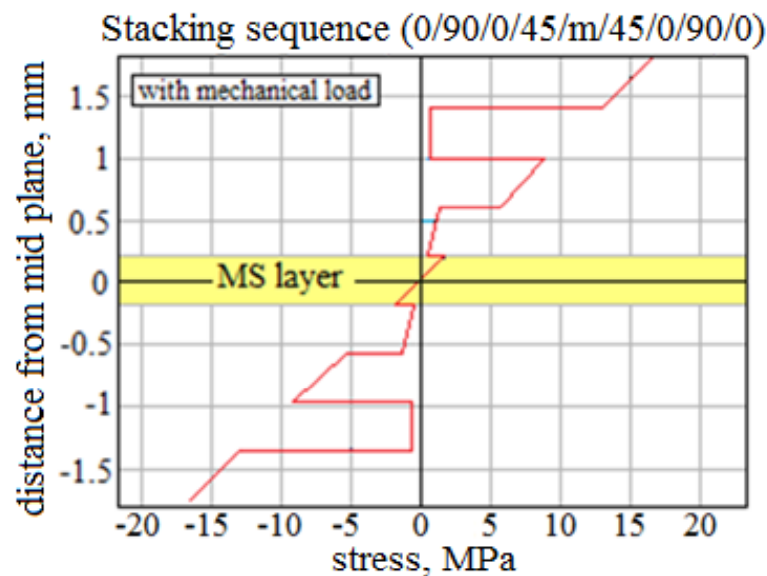
**Symmetric laminate**

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**Results...**

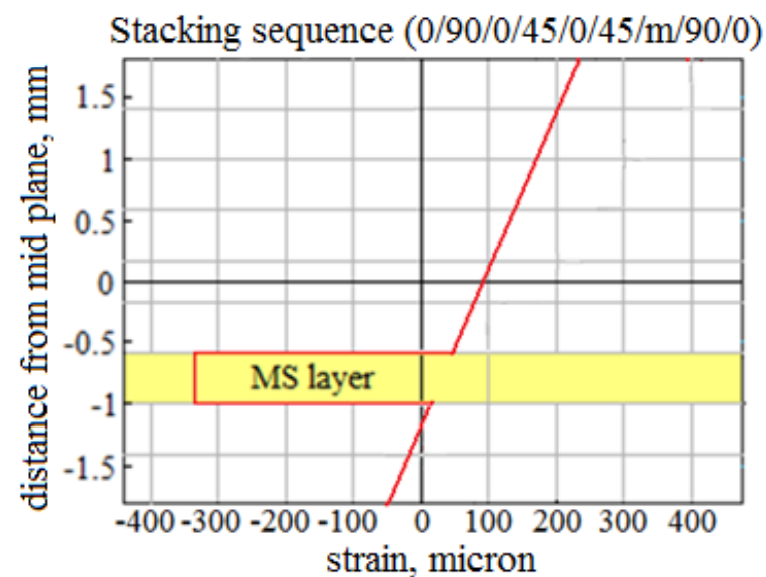
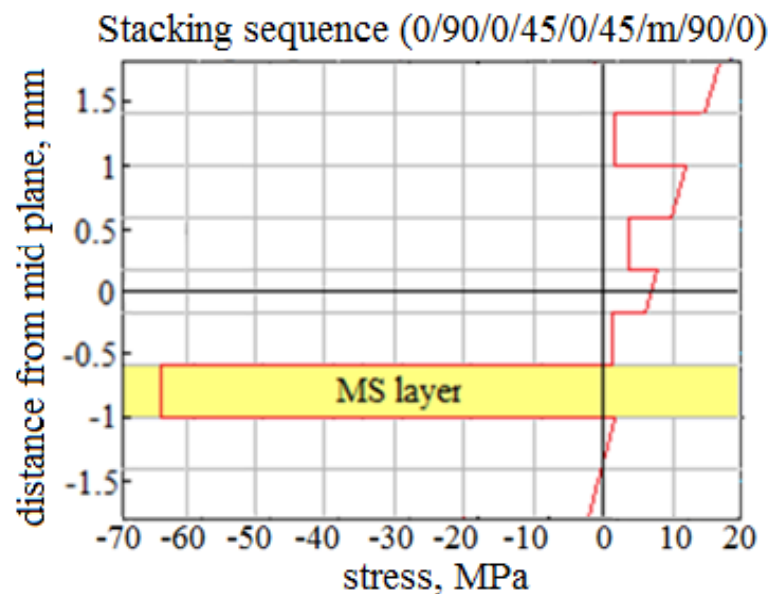
## Stress and Strain variations at various interfaces and in MS layer (mechanical load along with actuator current)



**Symmetric laminate**



## Stress and Strain variations at various interfaces and in MS layer (mechanical load along with actuator current)

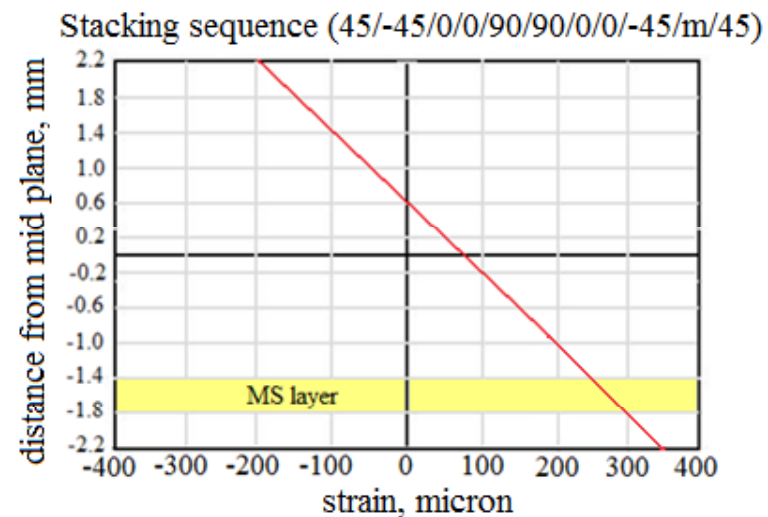
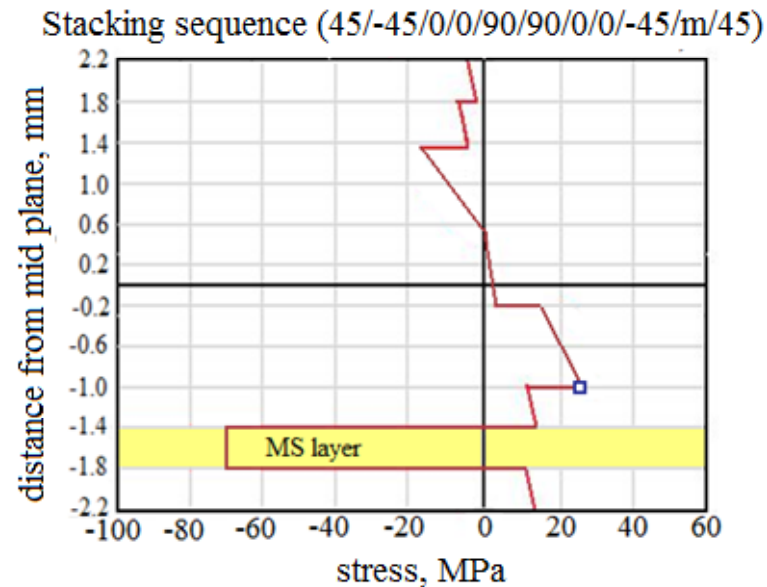


**Asymmetric laminate**

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## Stress and Strain variations at various interfaces and in MS layer (actuator current only)

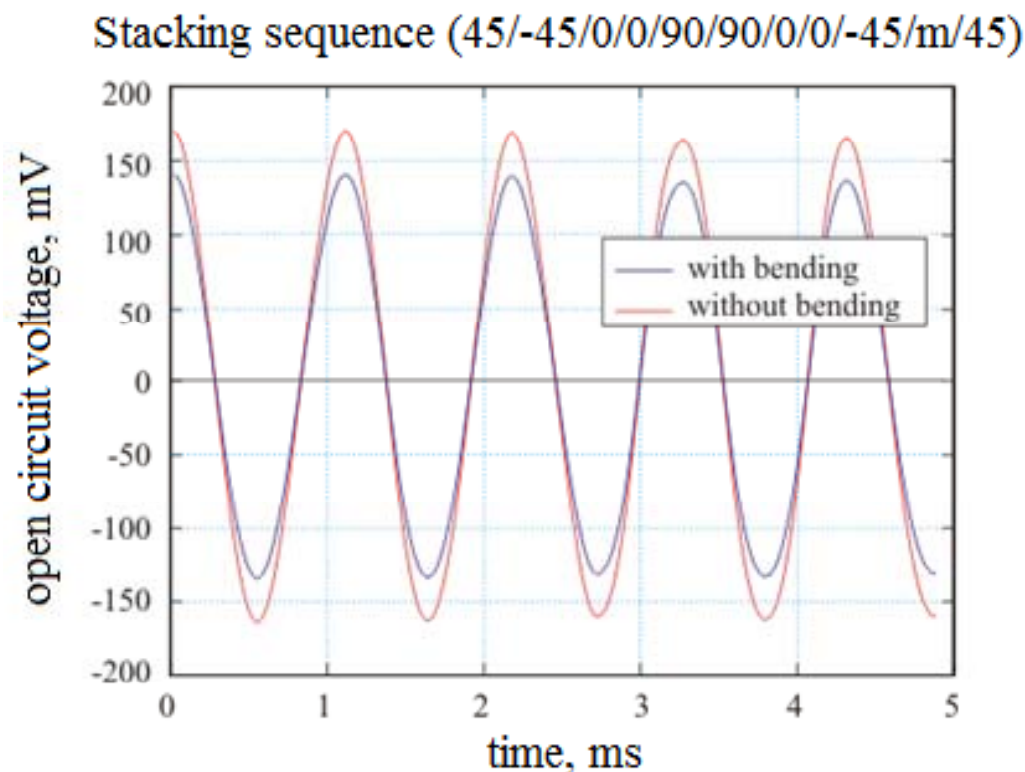


**Asymmetric laminate**

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## Open circuit voltage in MS layer at the time of delamination

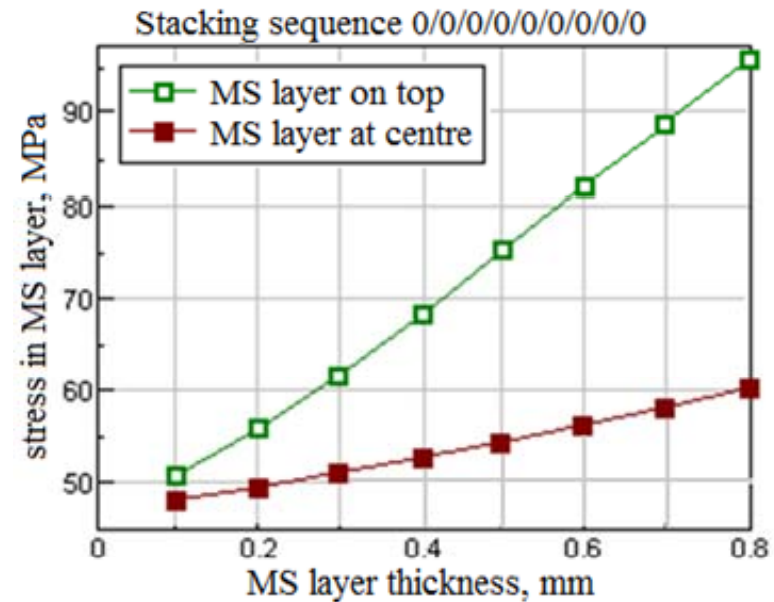
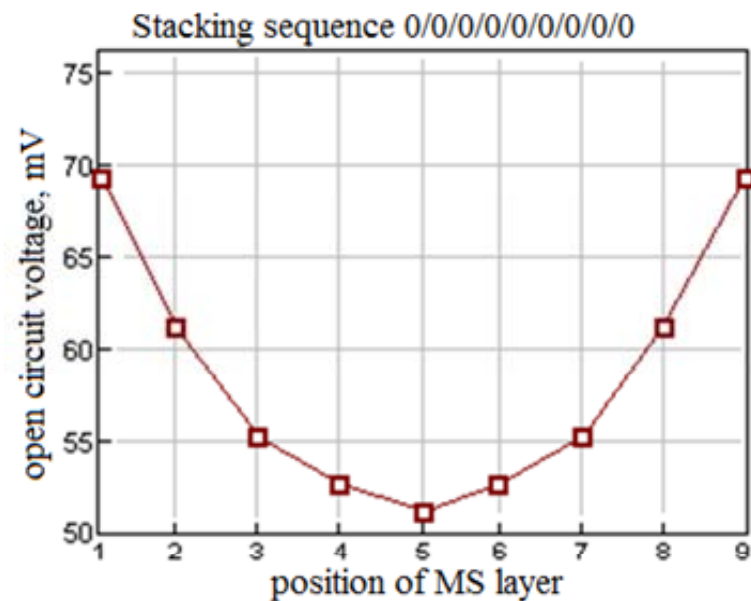


**with and without bending consideration**

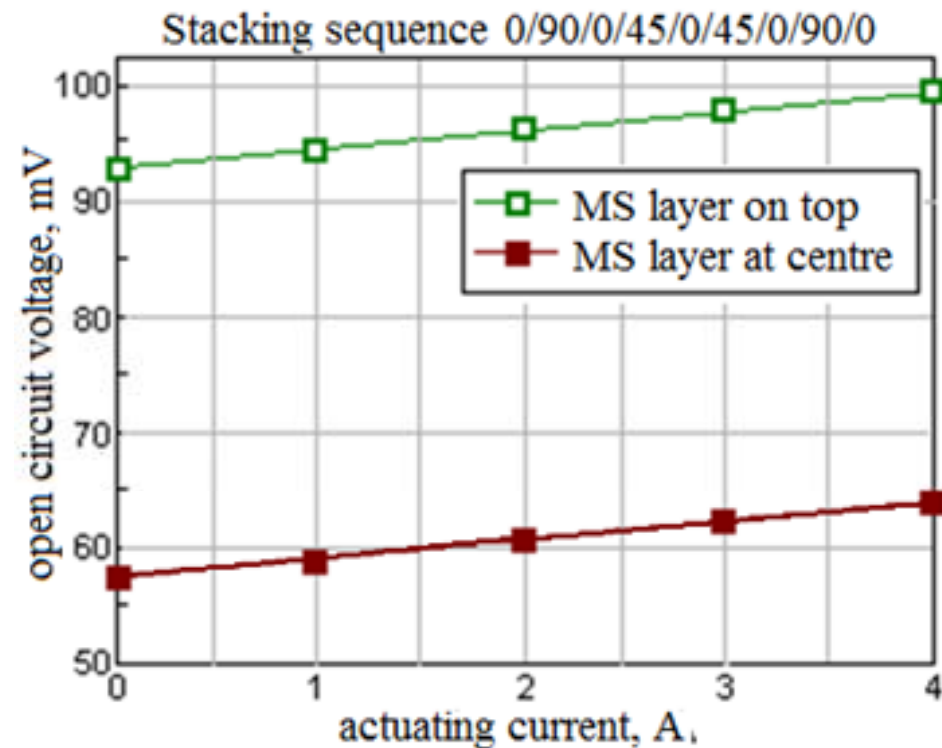
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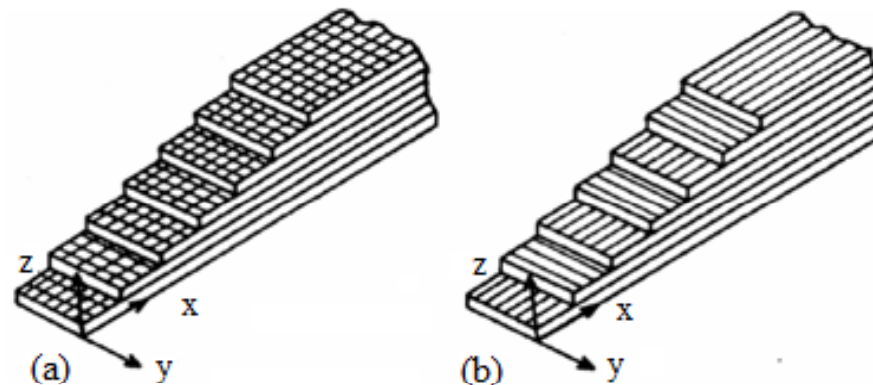
## Effect of position of MS layer and its thickness



## Open circuit voltage in the sensing coil with the increase in current in actuating coil.

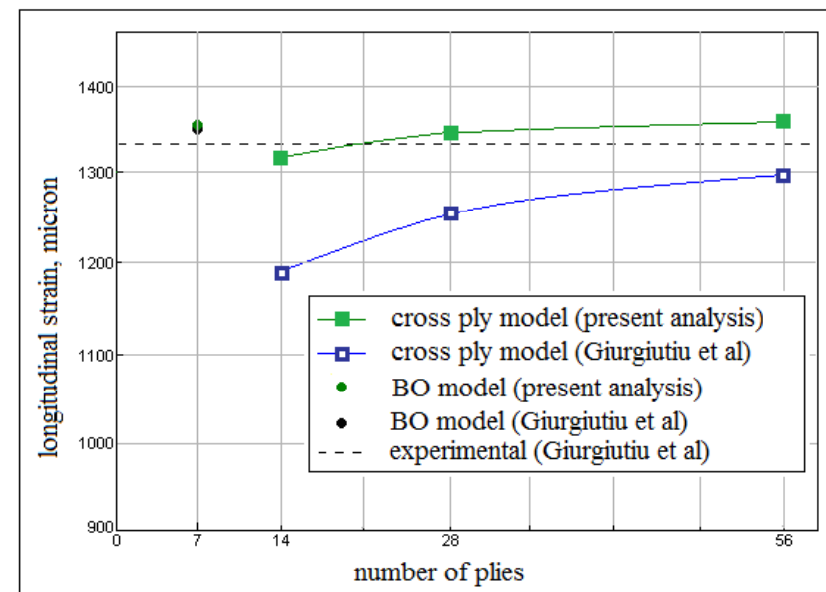
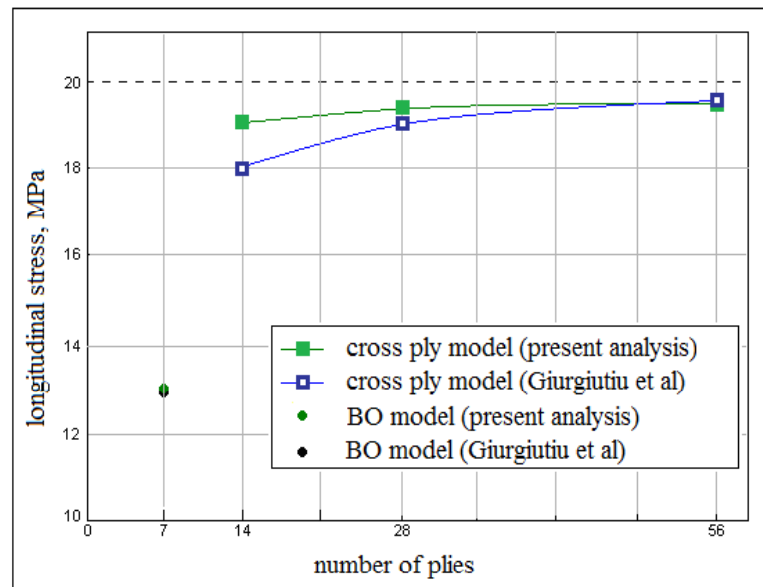


## Validation of present model for woven composite



(a) Balanced orthotropic and (b) Orthotropic cross ply layup models.

# Convergence of longitudinal stress and strain results on the beam surface under maximum load condition as predicted by various models



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## Major observations

- Variation of stress in delaminating interface and MS layer induces voltage in MS layer.
- Under axial loading, MS layer is subjected to compressive stresses while the remaining layers are under tension.
- In symmetrical laminates more than one interface can delaminate.
- MS layer thickness and location of the layer has a bearing on sensing voltage
- Effect of orientation of laminae is more prominent than bending effect.



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- [3] Krishnamurthy, A.V., Anjanappa, M. and Wu, Y-F., “Use of magnetostrictive particle actuators for vibration attenuation of flexible beams,” *Journal of Sound and Vibrations*, **206**, 33-49 (1997)
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